

Notice of References Cited	Application/Control No. 10/784,219	Applicant(s)/Patent Under Reexamination UNO, TOSHIHIKO	
	Examiner George C. Eckert II	Art Unit 2815	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,492,679 B1	12-2002	Imam et al.	257/342
	C	US-			
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	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	S. Wolf et al., Silicon Processing for the VLSI Era, Volume 1 - Process Technology, 1986, Lattice Press, pp. 26-28, 283-92.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.